Vaksis Vacuum Systems Bulletin Year: 7, No: 20, July 2017

PVD AND CVD COATING SYSTEMS FOR VARIOUS APPLICATIONS www.vaksis.com



architectural glass coating systems

new product MiCKS

activities

- PVD: Physical Vapor Deposition
- CVD: Chemical Vapor Deposition

VAKSIS®

AR-GE VE MÜHENDISLIK

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new product Vaksis / MiCKS





Vaksis MiCKS system is composed of prismatic vacuum chamber and involve the magnetron sputtering technique on glass panes or large wafers. It is designed for low-e coatings, anti-reflection coatings, electrochromic coatings, transparent conductive oxide coatings, nitride resistors, high conductivity coatings, etc.





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new product -





Technical Specifications:

Base Pressure ≤ 5x10-8 Torr Leak Rate ≤ 10-8 Torr.I/s Substrate Size Up to 30x30 cm Substrate Heating: Max. 400°C Cooling: Where necessary

Deposition Mode: Upward/Downward

Number of Sources: Max. 10 Power Supply: DC and/or RF Loading: Using load-lock chamber

Control: Fully Automatic



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activities

which we attended ...

YBU Career Day and R&D Centers Exhibition 2017, Ankara (9-10 May 2017)

https://aybukariyer2017.github.io/

Vaksis was at YBU Career Day and R&D Centers Exhibition 2017 which was held in Ankara, Turkey.



E-MRS 2017 Spring Meeting Strasbourg, France (22 - 26 May 2017)

http://www.european-mrs.com/meetings/2017-spring-meeting

Vaksis was one of the exhibitors of "E-MRS 2017 Spring Meeting" which was held in Strasbourg, France from May 22rd - 26th, 2017. Vaksis team was at booth #73 and met with related participants.



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